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February 19, 2004

Customer No.

23911

Mail Stop: Patent Application

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Re: New U.S. Patent Appln. Our Ref: 100929.53270US

Sir:

Transmitted herewith for filing is the patent application of:

Hideyuki KAZUMI, Tsuyoshi YOSHIDA, Eiji IKEGAMI, Kouichi NAKAUNE, Masamichi SAKAGUCHI, Yasuyuki MIYAMOTO and Akihiro SANO

Entitled: LSI DEVICE ETCHING METHOD AND APPARATUS THEREOF

Enclosed are:

- 1. Specification, including <u>13</u> claims (<u>37</u> pages).
- 2. <u>6</u> Sheets of Formal Drawings Showing Figures 1-9.
- 3. Declaration and Power of Attorney (Executed).
- 4. Application Data Sheet
- 5. Assignment of the invention to <u>Hitachi High-Technologies Corporation</u>
- 6. Certified copy of Priority Document <u>2003-203790</u> filed in <u>Japan</u> on <u>30 July 2003</u>, the priority of which is being claimed under 35 U.S.C. §119 and 37 C.F.R. §1.55.
- 7. Information Disclosure Statement w/1 reference.
- 8. The filing fee has been calculated as shown below:

 Basic Fee
 \$385/770 = \$770.00

 Total Claims
 13 - 20 = 0 x
 \$9/18 = \$

 Independent Claims
 4 - 3 = 1 x
 \$43/86 = \$86.00

 Multiple Dependent Claim Presented
 \$140/280 = \$

 Total Filing Fee
 \$856.00

Attorney Docket No.:100929.53270US PATENT

Two checks in the amount of \$856.00 for the filing fee and \$40.00 for the assignment recording fee are enclosed. The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Deposit Account No. 05-1323 (Docket #100929.53270US). A duplicate copy of this sheet is enclosed.

Respectfully submitted,

James F. McKeown

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